

EV372471501

MI22-1544



Application Serial No. 09/677,478
Response to October 26, 2004 NOA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/677,478
Filing Date October 2, 2000
Inventor Guy T. Blalock
Assignee Micron Technology, Inc.
Group Art Unit 1765
Examiner Lan Vinh
Attorney's Docket No. MI22-1544
Title: Plasma Etching Methods

**RESPONSE TO OCTOBER 26, 2004 NOTICE OF ALLOWANCE
TO ACCOMPANY REQUEST FOR CONTINUED EXAMINATION**

To: Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: D. Brent Kenady
Tel. 509-624-4276; Fax 509-838-3424
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Sir:

Responsive to the Notice of Allowance dated October 26, 2004,

Applicant amends and remarks as follows:

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.